



U.S. Patent Application Serial No. 09/934,262
Attorney Docket No. 03850/010001; Z8435-US/FS/OC

RECEIVED

OCT 22 2003

TC 1700

UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Oliver Kienzle et al.

Art Unit : 1756

Serial No.: 09/934,262

Examiner : John RUGGLES

Filed : August 21, 2001

Title : APPARATUS AND METHOD FOR EXPOSING A RADIATION SENSITIVE
LAYER BY MEANS OF CHARGED PARTICLES AS WELL AS A MASK
FOR THIS PURPOSE

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

22511

PATENT TRADEMARK OFFICE

REPLY UNDER 37 CFR § 1.111

In response to the Restriction Requirement dated September 12, 2003, please
amend the application as follows and consider the included remarks.